

## APPLICATION DATA SHEET

### APPLICATION INFORMATION

Application Type::	REGULAR
Subject Matter::	UTILITY
CD-ROM or CD-R?::	NONE
Title::	WAFER PROCESSING APPARATUS HAVING DUST PROOF FUNCTION
Attorney Docket Number::	245161US3 CIP
Total Drawing Sheets::	7

### INVENTOR INFORMATION

Applicant Authority Type::	INVENTOR
Primary Citizenship Country::	Japan
Status::	FULL CAPACITY
Given Name::	Tsutomu
Family Name::	OKABE
City of Residence::	Tokyo
Country of Residence::	JAPAN
Street of Mailing Address::	c/o TDK Corporation, 1-13-1, Nihonbashi, Chuo-ku
City of Mailing Address::	Tokyo
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	103-8272

Applicant Authority Type::	INVENTOR
Primary Citizenship Country::	Japan
Status::	FULL CAPACITY
Given Name::	Hiroshi
Family Name::	IGARASHI
City of Residence::	Tokyo
Country of Residence::	JAPAN
Street of Mailing Address::	c/o TDK Corporation, 1-13-1, Nihonbashi, Chuo-ku
City of Mailing Address::	Tokyo
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	103-8272

### CORRESPONDENCE INFORMATION

Correspondence Customer Number::	22850
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## REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

## DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Continuation-in-Part of	10/330,092	12/30/02

## ASSIGNMENT INFORMATION

Assignee Name:: TDK CORPORATION  
Street of Mailing Address:: 1-13-1, Nihonbashi, Chuo-ku,  
City of Mailing Address:: Tokyo  
Country of Mailing Address:: Japan